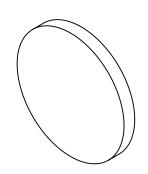
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 765 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 735nm @ 0° AOI T(abs): =50% FOR 750±7.5nm @ 0° AOI

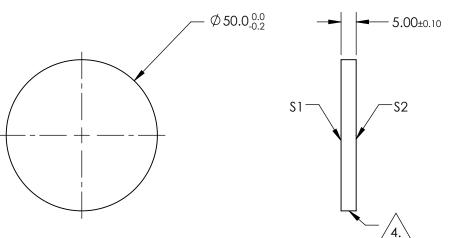
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER			Edmund Opt			
REV A	S1	S2				<i>,</i> 3
SHAPE	PLANO	PLANO			Ø50mm, 750nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				CULLET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	84761	SHEET 1 OF 1

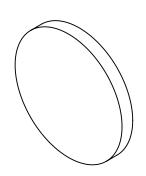
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 815 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 785nm @ 0° AOI T(abs): =50% FOR 800±8nm @ 0° AOI

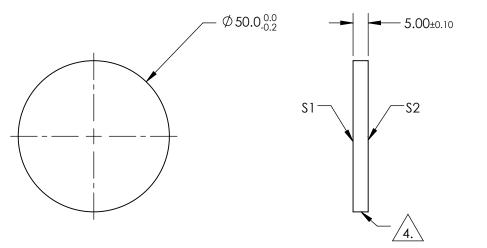
S2:SINGLE LAYER MgF2

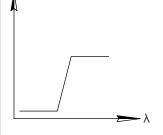
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optic	۲C®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø50mm, 800nm, HIGH PERFORMAN	ICE
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84762	SHEET 1 OF 1

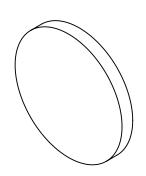
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 865 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 835nm @ 0° AOI T(abs): =50% FOR 850±8.5nm @ 0° AOI

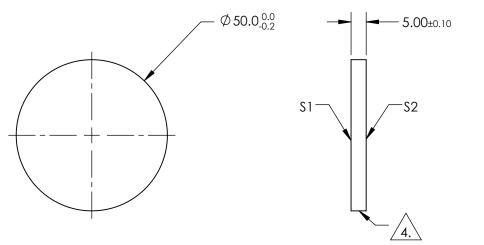
S2:SINGLE LAYER MgF2

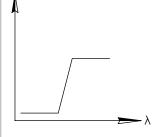
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			1 Edmund Opt				۲C®
REV A	S1	S2					5
SHAPE	PLANO	PLANO				Ø50mm, 850nm, HIGH PERFORMAN	ICE
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84763	SHEET 1 OF 1

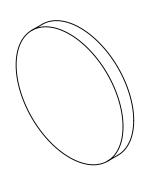
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 915 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 880nm @ 0° AOI T(abs): =50% FOR 900±9nm @ 0° AOI

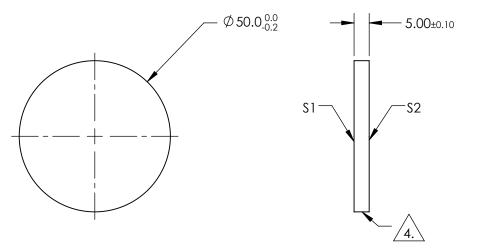
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

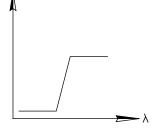
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGI / 03 HETEK			_		Edmund Optics [®]	
REV A	S1	\$2				
SHAPE	PLANO	PLANO			Ø50mm, 900nm, HIGH PERFORMANCE	
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%			SHEET	
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	84764 SHEET 1 OF 1	

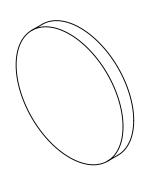
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 965 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 930nm @ 0° AOI T(abs): =50% FOR 950±9.5nm @ 0° AOI

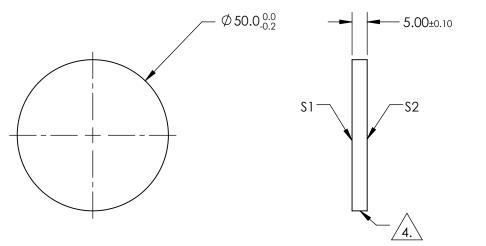
S2:SINGLE LAYER MgF2

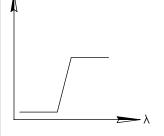
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER					[®] Edmund Optics [®]
REV A	S1	S2			
SHAPE	PLANO	PLANO			Ø50mm, 950nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%			
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	84765 SHEET 1 OF 1

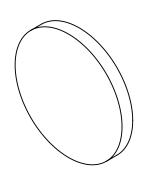
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1020 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 980nm @ 0° AOI T(abs): =50% FOR 1000±10nm @ 0° AOI

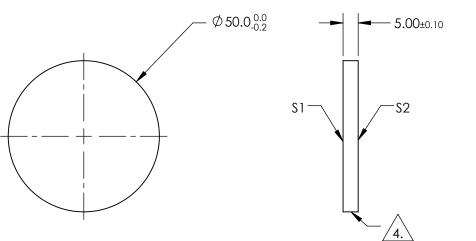
S2:SINGLE LAYER MgF2

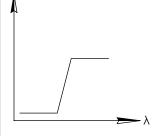
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER				Edmund Option			
REV A	S1	S2					<i>.</i> ວ
SHAPE	PLANO	PLANO				Ø50mm, 1000nm, HIGH PERFORMAN	JCF
SURFACE QUALITY	40-20	40-20	THIRD ANGLE		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84766	SHEET 1 OF 1

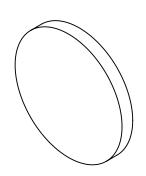
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1070 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 1030nm @ 0° AOI T(abs): =50% FOR 1050±10.5nm @ 0° AOI

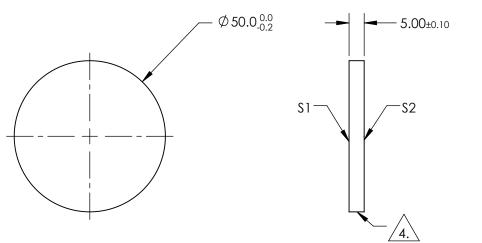
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

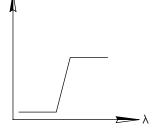
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGINGSTILLER						Edmund Optic	C ®
REV A	S1	S2					, ວ
SHAPE	PLANO	PLANO				Ø50mm, 1050nm, HIGH PERFORMAN	CE
SURFACE QUALITY	40-20	40-20	THIRD ANGLE . PROJECTION	$\bigcirc \bigcirc \bigcirc$	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			SHEET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	84767	1 OF 1

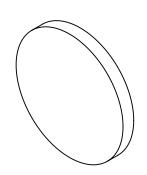
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1120 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 1080nm @ 0° AOI T(abs): =50% FOR 1100±11nm @ 0° AOI

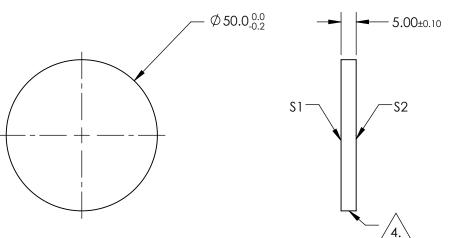
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGINGOTIETER					Edmund Optics [®]		
REV A	S1	S2				. <u>Э</u>	
SHAPE	PLANO	PLANO			Ø50mm, 1100nm, HIGH PERFORMAN	CF	
SURFACE QUALITY	40-20	40-20	THIRD ANGLE	TITLE	LONGPASS FILTER		
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	84768	Sheet 1 Of 1	

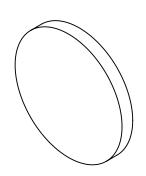
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 735 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 705nm @ 0° AOI T(abs): =50% FOR 725±7.25nm @ 0° AOI

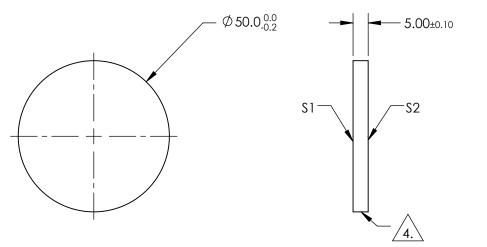
S2:SINGLE LAYER MgF2

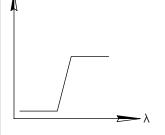
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER					Edmund Optics [®]		
REV A	S1	S2				5	
SHAPE	PLANO	PLANO			Ø50mm, 725nm, HIGH PERFORMAN	CF	
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER		
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	86076	Sheet 1 Of 1	

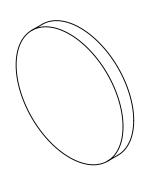
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 790 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 760nm @ 0° AOI T(abs): =50% FOR 775±7.75nm @ 0° AOI

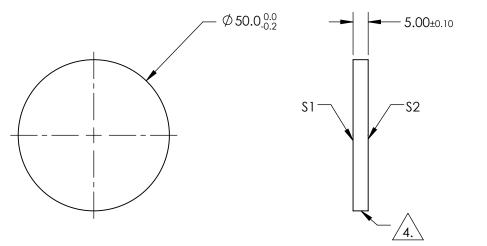
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

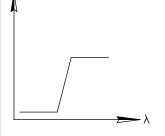
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGITIGGT			_		Edmund Optics ®		
REV A	S1	S2					
SHAPE	PLANO	PLANO				Ø50mm, 775nm, HIGH PERFORMANC	`F
SURFACE QUALITY	40-20	40-20	THIRD ANGLE . PROJECTION	THIRD ANGLE		LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%		1			SULLET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86077	Sheet 1 Of 1

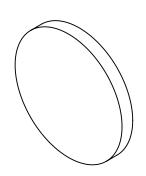
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 840 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 805nm @ 0° AOI T(abs): =50% FOR 825±8.25nm @ 0° AOI

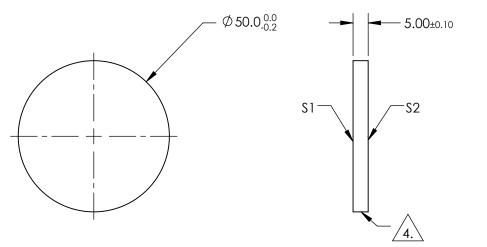
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

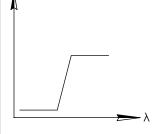
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER

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LONGINGSTILLER					Edmund Optics	R
REV A	S1	S2				
SHAPE	PLANO	PLANO			Ø50mm, 825nm, HIGH PERFORMANC	F
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				SULLET
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	86078	Sheet 1 of 1

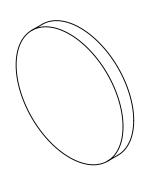
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 890 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 860nm @ 0° AOI T(abs): =50% FOR 875±8.75nm @ 0° AOI

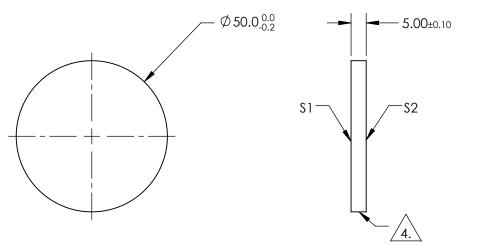
S2:SINGLE LAYER MgF2

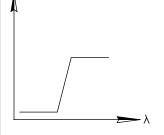
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optics [®]
REV A	S1	S2				
SHAPE	PLANO	PLANO				Ø50mm, 875nm, HIGH PERFORMANCE
SURFACE QUALITY	40-20	40-20			TITLE	LONGPASS FILTER
CLEAR APERTURE	>80%	>80%		1		
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86079 SHEET 1 OF 1

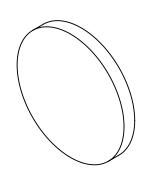
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 940 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 905nm @ 0° AOI T(abs): =50% FOR 925±9.25nm @ 0° AOI

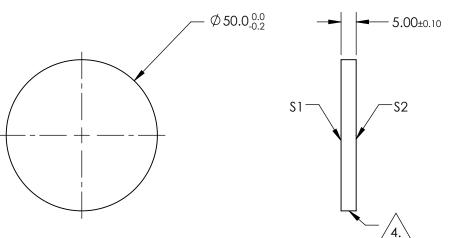
S2:SINGLE LAYER MgF2

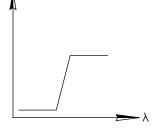
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









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LONGPASS FILTER			_			Edmund Optics	C ®
REV A	S1	S2					5
SHAPE	PLANO	PLANO	-		Ø50mm, 925nm, HIGH PERFORMANCE LONGPASS FILTER		
SURFACE QUALITY	40-20	40-20	THIRD ANGLE				TITLE
CLEAR APERTURE	>80%	>80%		1			CUEFT
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN	mm	DWG NO	86080	Sheet 1 Of 1

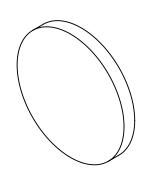
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 990 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 955nm @ 0° AOI T(abs): =50% FOR 975±9.75nm @ 0° AOI

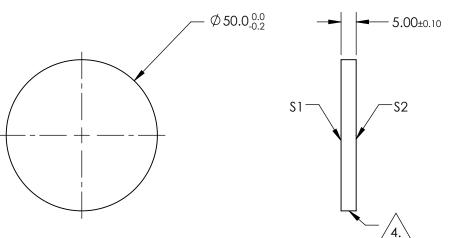
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







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LONGPASS FILTER			H® Edmund Optics [®]			
REV A	S1	S2				<i>,</i> 3
SHAPE	PLANO	PLANO			Ø50mm, 975nm, HIGH PERFORMAN	CF
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	86081	SHEET 1 OF 1

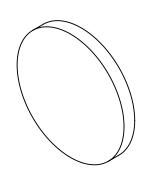
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1045 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 1005nm @ 0° AOI T(abs): =50% FOR 1025±10.25nm @ 0° AOI

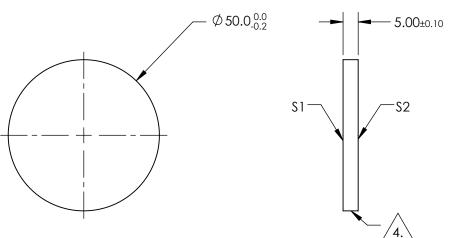
S2:SINGLE LAYER MgF2

4. FINE GRIND SURFACE

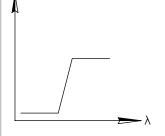
- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT







6



LONGPASS FILTER

Τ

LONGINGSTIELER			Edmund Optics			
REV A	S1	S2				3
SHAPE	PLANO	PLANO			Ø50mm, 1025nm, HIGH PERFORMANC	∩F
SURFACE QUALITY	40-20	40-20	THIRD ANGLE	TITLE	LONGPASS FILTER	
CLEAR APERTURE	>80%	>80%				CLIEFT
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	86082	Sheet 1 Of 1

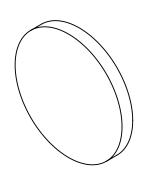
- 1. SUBSTRATE
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
- COATING (APPLY ACROSS COATING APERTURE) S1: HARD DIELECTRIC SPUTTERED T(avg): ≥91% FROM 1095 - 1650nm @ 0° AOI T(avg): ≤0.01% FROM 200 - 1055nm @ 0° AOI T(abs): =50% FOR 1075±10.75nm @ 0° AOI

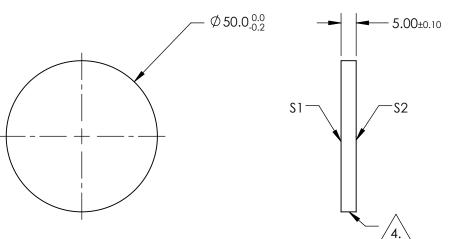
S2:SINGLE LAYER MgF2

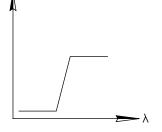
4. FINE GRIND SURFACE

- 5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
- 6. TRANSMITTED WAVEFRONT DISTORTION, RMS: ≤λ/4 @ 633nm
- 7. ROHS COMPLIANT









Τ

LONGPASS FILTER				Edmund Optic	с®		
REV A	S1	S2				<i>,</i> 3	
SHAPE	PLANO	PLANO			Ø50mm, 1075nm, HIGH PERFORMANCE		
SURFACE QUALITY	40-20	40-20		TITLE	LONGPASS FILTER		
CLEAR APERTURE	>80%	>80%					
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	ALL DIMS IN mm	DWG NO	86083	SHEET 1 OF 1	